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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Dai KOBAYASHI, et al.

SERIAL NO.: NEW U.S. PCT APPLICATION

FILED: HEREWITH

INTERNATIONAL APPLICATION NO.: PCT/JP04/11351

INTERNATIONAL FILING DATE: August 6, 2004

FOR: PROBE FOR PROBE MICROSCOPE USING TRANSPARENT SUBSTRATE,
METHOD OF PRODUCING THE SAME, AND PROBE MICROSCOPE DEVICE

REQUEST FOR PRIORITY UNDER 35 U.S.C. 119
AND THE INTERNATIONAL CONVENTION

Commissioner for Patents
Alexandria, Virginia 22313

Sir:

In the matter of the above-identified application for patent, notice is hereby given that the applicant claims as priority:

COUNTRY
Japan

APPLICATION NO
2003-290989

DAY/MONTH/YEAR
11 August 2003

Certified copies of the corresponding Convention application(s) were submitted to the International Bureau in PCT Application No. PCT/JP04/11351.

Respectfully submitted,
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